

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/550,450	ICHIMURA ET AL.	
Examiner	Art Unit	
Marina Kramskaya	2858	

SEARCHED					
Class	Subclass	Date	Examiner		
324	663	7/9/2006	МК		
324	522	7/9/2006	мк		
324	713	7/9/2006	мк		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		- - -		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
search 73/514.01-5201.01 with keyowrd for MEMS type sensors	7/9/2006	MK		
Review international search report	7/9/2006	MK		